## **EAST Search History**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1869	(thickness same imag\$3) same (database library map\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:01
L2	1869	(thickness same imag\$3) same (database library map\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:01
L3	768	L2 and (substrate semiconduct\$3 wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:01
L4	4756	(356/600,630,394,237.1,239.1,239.3, 239.7,237.2,237.3,237.4;237.5).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L5	3428	(438/7,14,16).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L6	2386	(382/141,145,149,152).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L7	872	(348/92,93,125,126,128).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L8	768	L2 and (substrate semiconduct\$3 wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:02
L9	4756	(356/600,630,394,237.1,239.1,239.3, 239.7,237.2,237.3,237.4,237.5).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L10	3428	(438/7,14,16).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L11	2386	(382/141,145,149,152).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02

## **EAST Search History**

L12	872	(348/92,93,125,126,128).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L13	1277	(250/559.04,559.05,559.06,559.07, 559.08,559.19,559.20,559.22,559.27, 559.28).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/22 18:02
L14	65	(L9 L10 L11 L12 L13) and L8	US-PGPUB; USPAT; USOCR	OR	ON	2007/03/22 18:02
L15	742	(L8 L9 L10 L11 L12 L13) and L8	US-PGPUB; USPAT; USOCR	OR	ON	2007/03/22 18:03
L16	785	(optic\$ same imag\$3) same sem	USPAT	OR	ON	2007/03/22 18:03
L17	785	(optic\$ same imag\$3) same sem	USPAT	OR	ON	2007/03/22 18:03
L18	217	L17 same wafer	USPAT	OR	ON	2007/03/22 18:03
L19	307	L2 same (substrate semiconduct\$3 wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:04
L20	65	(L9 L10 L11 L12 L13) and L8	US-PGPUB; USPAT; USOCR	OR	ON	2007/03/22 18:04
L21	307	L2 same (substrate semiconduct\$3 wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:04
L22	266	L21 not L20	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/22 18:04